

# EUROPEAN PATENT OFFICE

## Patent Abstracts of Japan

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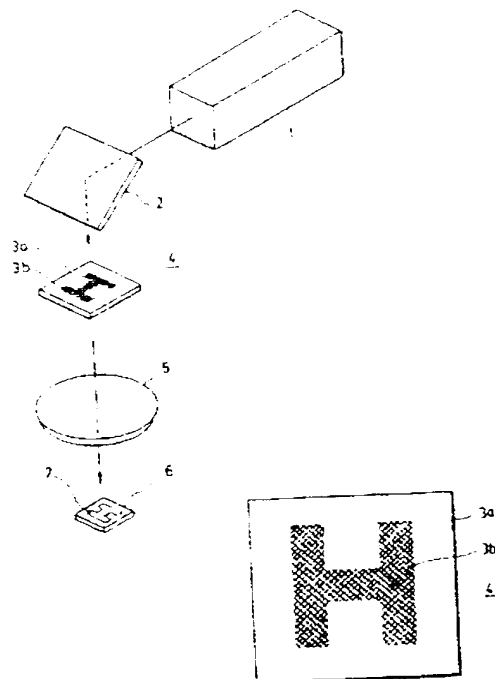
APPLICATION DATE : 28-12-89  
APPLICATION NUMBER : 01338355

APPLICANT : USHIO INC;

INVENTOR : MIKAMI MASAYOSHI;

INT.CL. : C03C 19/00 C03C 23/00

TITLE : MASK AND METHOD FOR MARKING  
GLASS WITH MASK



ABSTRACT : PURPOSE: To form a clear pattern and to mark glass by selecting a mask for laser beam marking composed of a metallic substrate and a specified metallic mesh.

CONSTITUTION: A mask 4 for laser beam marking composed of a metallic substrate 3a and a metallic mesh 3b formed into a pattern to be marked is selected.

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